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DESIGN OF SOL-GEL MESOPOROUS COATINGS FOR ANTI-FINGERPRINT APPLICATIONS ON GLASS

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Abstract

Nowadays, the use of mesoporous sol-gel films as smart coatings is growing. Their porosity is used to embed active species in applications such as drug delivery, catalysis, sensors, active corrosion protection, ... The film mesoporosity is produced by evaporation induced self-assembly (EISA) process. This process is based on the addition of a templating agent in sol-gel formulation. The thermal removal of surfactant agent allows to control the coating mesostructure. In this work, the mesostructure of the sol-gel layer is designed to be used as reservoir for active biomolecules. In order to assure a good incorporation and storage of biomolecules, the size of mesopores and their configuration were tuned as a function of application and synthesis parameters. The effects of the sol-gel composition and deposition process on the sol-gel mesostructure were evaluated. Scanning electron microscopy (SEM) and water adsorption/desorption isotherms recorded with a quartz crystal microbalance (QCM) were used to characterize the morphologies of the sol-gel film. Rheological measurements were carried out to check the stability of the sol-gel solution. The anti-fingerprint performance due to the combination of mesoporous film and enzymatic solutions were assessed by using an artificial sebum.

Keywords: mesoporous, anti-fingerprint, evaporation induced self-assembly

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